10/564853

IAP20 Rec'd PCT/PTO 17 JAN 2006

Our Ref: JHTK-86-PCT-US

January 13, 2006

English Translation of Amendment under PCT Article 34 PCT/JP2004/010184

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CLAIMS

- 1. (Amended) A negative photosensitive resin composition for forming projections having a curved surface, comprising an alkali-soluble resin (a), a reactive monomer (b), and a photoreaction initiator (c), wherein 50% or more of a total mass of the blended reactive monomer (b) is a monofunctional reactive monomer.
- 2. (Amended) The negative photosensitive resin composition for forming projections according to claim 1, wherein a surface shape of the projections is a smoothly curved surface.
- 3. (Amended) The negative photosensitive resin composition for forming projections according to either claim 1 or claim 2, wherein a height of the projections is within a range from 0.5 to $5 \mu m$.
- 4. (Amended) The negative photosensitive resin composition for forming projections according to any one of claim 1 through claim 3, wherein precision of the height of the projections is no greater than \pm 0.1 μ m.
- 5. (Amended) The negative photosensitive resin composition for forming projections according to any one of claim 1 through claim 4, wherein a proportion of the monofunctional reactive monomer within the total mass of the blended reactive monomer (b) is within a range from 50 to 90% by mass.
- 6. (Amended) The negative photosensitive resin composition for forming projections according to claim 5, wherein a proportion of the monofunctional reactive monomer within the total mass of the blended reactive monomer (b) is within a range from 60 to 85% by mass.

- 7. (Amended) The negative photosensitive resin composition for forming projections according to claim 6, wherein a proportion of the monofunctional reactive monomer within the total mass of the blended reactive monomer (b) is within a range from 70 to 80% by mass.
- 8. (Amended) A negative photosensitive resin composition for forming projections for controlling liquid crystal alignment, comprising an alkali-soluble resin (a), a reactive monomer (b), and a photoreaction initiator (c), wherein 50% or more of a total mass of the blended reactive monomer (b) is a monofunctional reactive monomer.
- 9. (New) The negative photosensitive resin composition for forming projections for controlling liquid crystal alignment according to claim 8, wherein a surface shape of the projections is a smoothly curved surface.
- 10. (New) The negative photosensitive resin composition for forming projections for controlling liquid crystal alignment according to either claim 8 or claim 9, wherein a height of the projections is within a range from 0.5 to 5 µm.
- 11. (New) The negative photosensitive resin composition for forming projections for controlling liquid crystal alignment according to any one of claim 8 through claim 10, wherein precision of the height of the projections is no greater than \pm 0.1 μ m.
- 12. (New) The negative photosensitive resin composition for forming projections for controlling liquid crystal alignment according to any one of claim 8 through claim 11, wherein a proportion of the monofunctional reactive monomer within the total mass of the blended reactive monomer (b) is within a range from 50 to 90% by mass.
- 13. (New) The negative photosensitive resin composition for forming projections for controlling liquid crystal alignment according to claim 12, wherein a proportion of the

monofunctional reactive monomer within the total mass of the blended reactive monomer (b) is within a range from 60 to 85% by mass.

- 14. (New) The negative photosensitive resin composition for forming projections for controlling liquid crystal alignment according to claim 13, wherein a proportion of the monofunctional reactive monomer within the total mass of the blended reactive monomer (b) is within a range from 70 to 80% by mass.
- 15. (New) A negative photosensitive element, comprising a negative photosensitive resin composition layer that uses either the negative photosensitive resin composition for forming projections according to any one of claim 1 through claim 7, or the negative photosensitive resin composition for forming projections for controlling liquid crystal alignment according to any one of claim 8 through claim 14, positioned on top of a support.
- 16. (New) A method of producing projections having a curved surface, comprising at least:
- (I) a step of layering either the negative photosensitive resin composition according to any one of claim 1 through claim 14, or the negative photosensitive resin composition layer of the negative photosensitive element according to claim 15 onto a substrate, thereby forming a negative photosensitive resin composition layer on top of the substrate,
- (II) a step of patterning the negative photosensitive resin composition layer by irradiation with an activation light beam,
 - (III) a step of generating a resin pattern by developing, and
 - (IV) a step of heating the resin pattern.
- 17. (New) A method of producing projections for controlling liquid crystal alignment, comprising at least:

- (I) a step of layering either the negative photosensitive resin composition according to any one of claim 1 through claim 14, or the negative photosensitive resin composition layer of the negative photosensitive element according to claim 15 onto a substrate, thereby forming a negative photosensitive resin composition layer on top of the substrate,
- (II) a step of patterning the negative photosensitive resin composition layer by irradiation with an activation light beam,
 - (III) a step of generating a resin pattern by developing, and
 - (IV) a step of heating the resin pattern.
- 18. (New) A method of producing projections for controlling liquid crystal alignment, comprising at least:
- (I) a step of layering either the negative photosensitive resin composition according to any one of claim 1 through claim 14, or the negative photosensitive resin composition layer of the negative photosensitive element according to claim 15 onto a substrate, thereby forming a negative photosensitive resin composition layer on top of the substrate,
- (Π) a step of patterning the negative photosensitive resin composition layer by irradiation with an activation light beam,
 - (III) a step of generating a resin pattern by developing, and
 - (IV) a step of generating projections having smoothly curved surfaces by heating.
- 19. (New) Projections having curved surfaces, produced using the method according to claim 16.
- (New) Projections for controlling liquid crystal alignment, produced using the method according to either claim 17 or claim 18.

- 21. (New) A substrate having either the projections having curved surfaces according to claim 19, or the projections for controlling liquid crystal alignment according to claim 20.
- 22. (New) A liquid crystal panel that is produced using the substrate having projections for controlling liquid crystal alignment according to claim 21.